

<b>Notice of References Cited</b>	Application/Control No. 08/102,390	Applicant(s)/Patent Under Reexamination SKOULTCHI, ARTHUR I.	
	Examiner SHIN LIN CHEN	Art Unit 1632	Page 1 of 1

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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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